

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : S.V. Sreenivasan et al. Art Unit : 1732  
Serial No. : 10/788,700 Examiner : Matthew J. Daniels  
Filed : February 27, 2004 Conf. No. : 6995  
Title : FULL-WAFER OR LARGE AREA IMPRINTING WITH MULTIPLE  
SEPARATED SUB-FIELDS FOR HIGH THROUGHPUT LITHOGRAPHY

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

In response to the Office Action having a mailing date of March 23, 2007, with a three-month shortened statutory period set to expire on June 23, 2007, please amend the above identified application as follows: